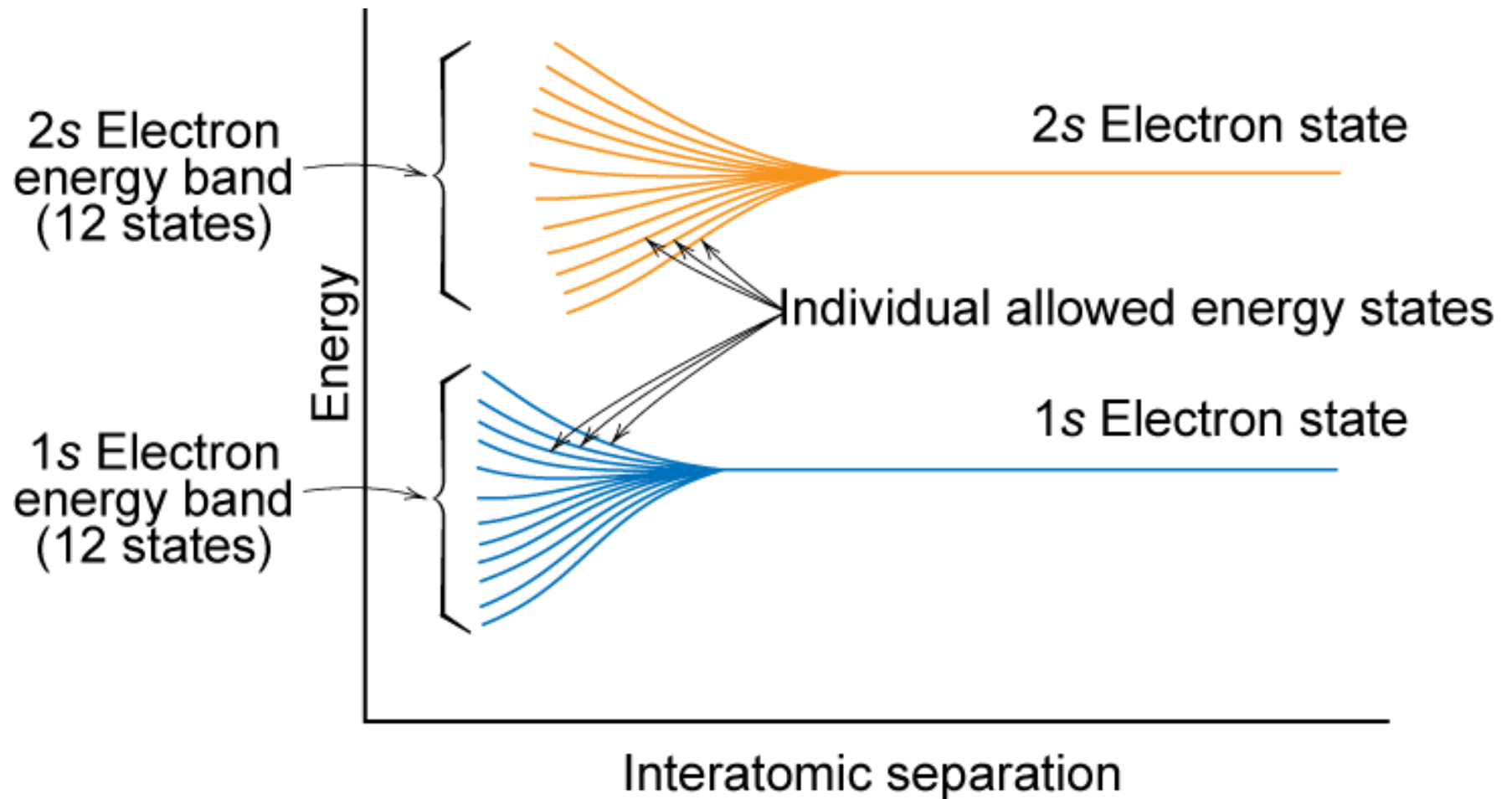


Chapter 18: Electrical Properties

- What are the physical phenomena that distinguish conductors, semiconductors, and insulators?
- For metals, how is conductivity affected by imperfections, T , and deformation?
- For semiconductors, how is conductivity affected by impurities (doping) and T ?



Electronic Band Structures

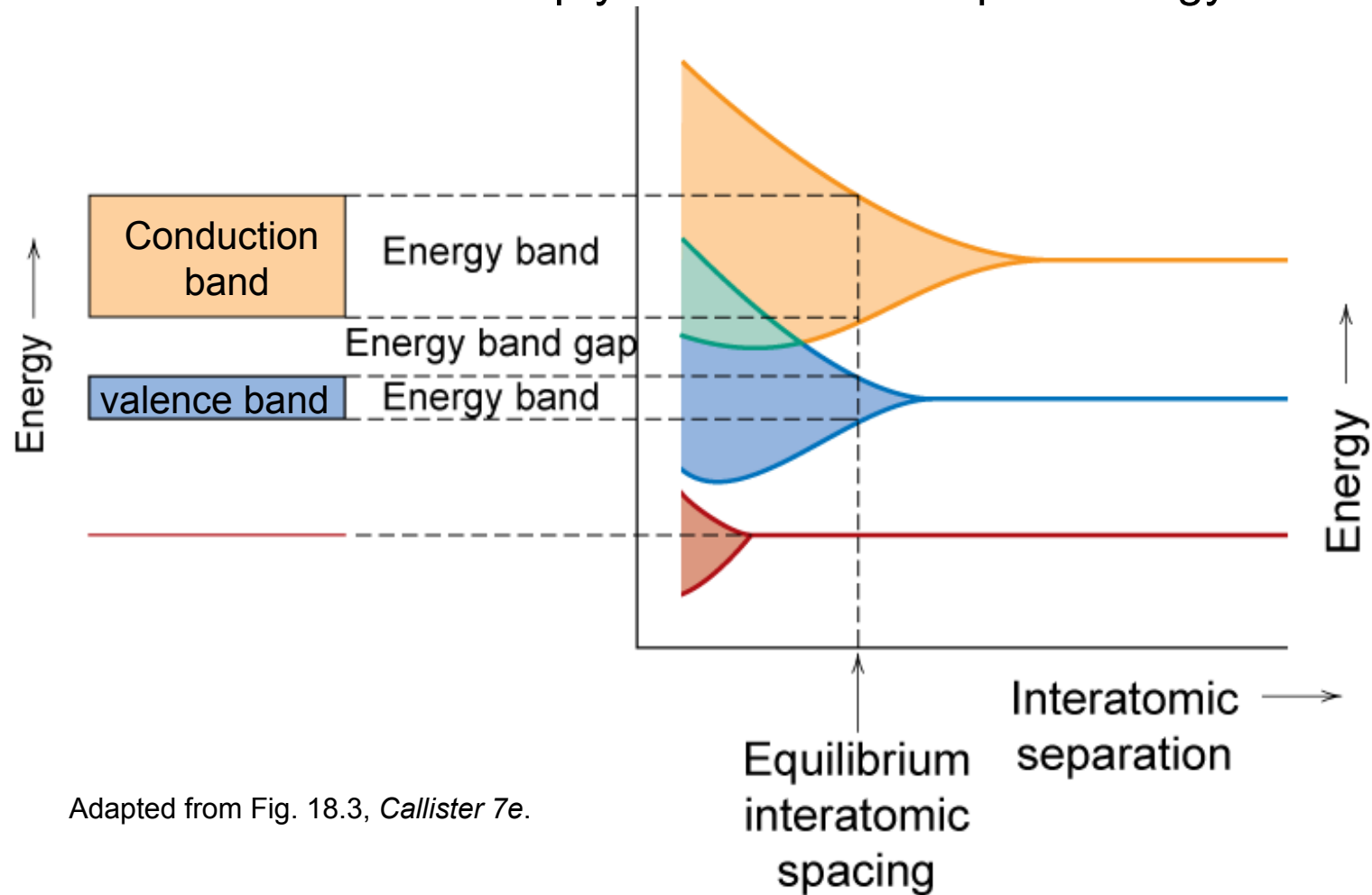


Adapted from Fig. 18.2, *Callister 7e*.



Band Structure

- Valence band – filled – highest occupied energy levels
- Conduction band – empty – lowest unoccupied energy levels

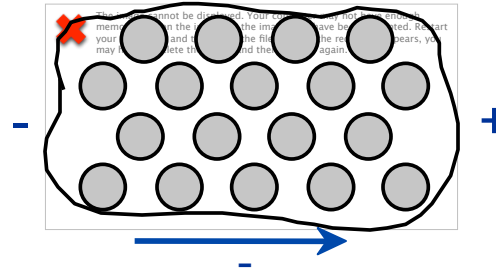


Adapted from Fig. 18.3, *Callister 7e*.

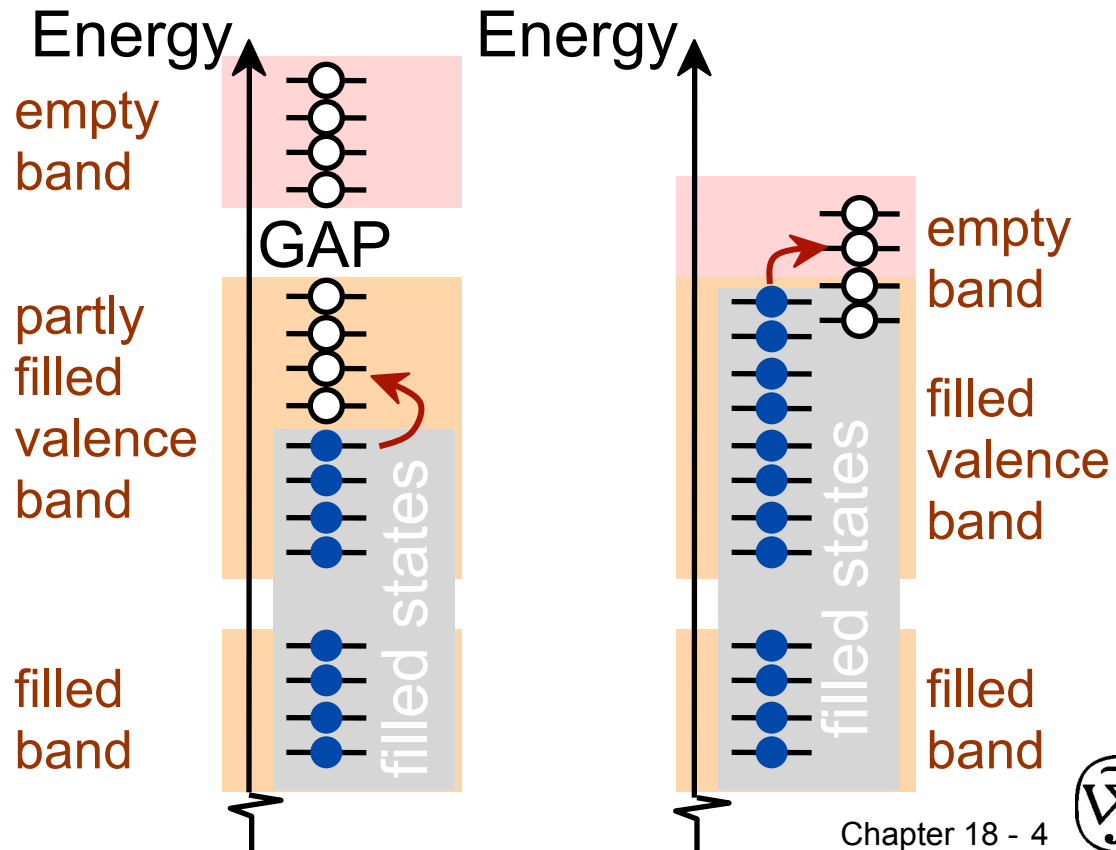


Conduction & Electron Transport

- Metals (**Conductors**):
- Thermal energy puts many electrons into a higher energy state.

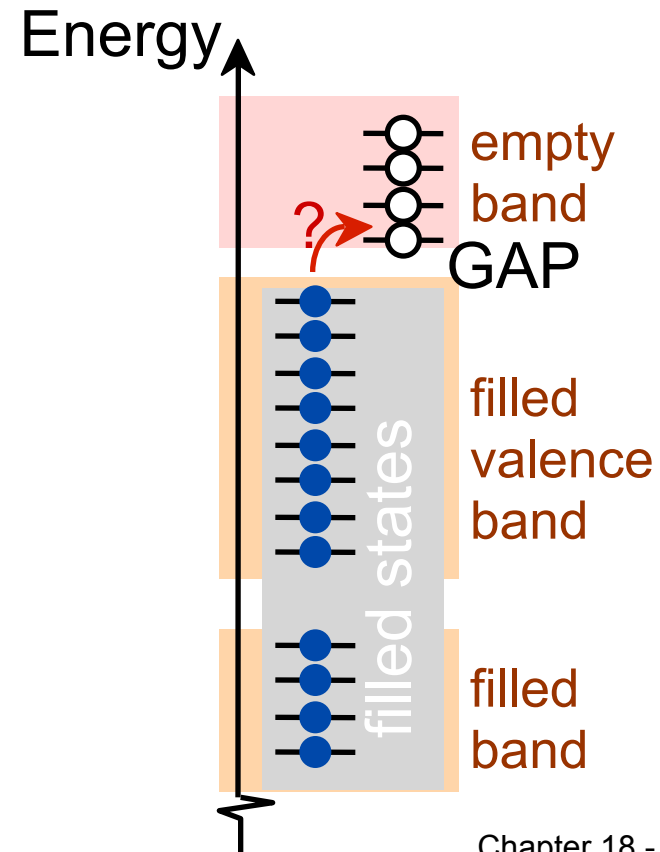
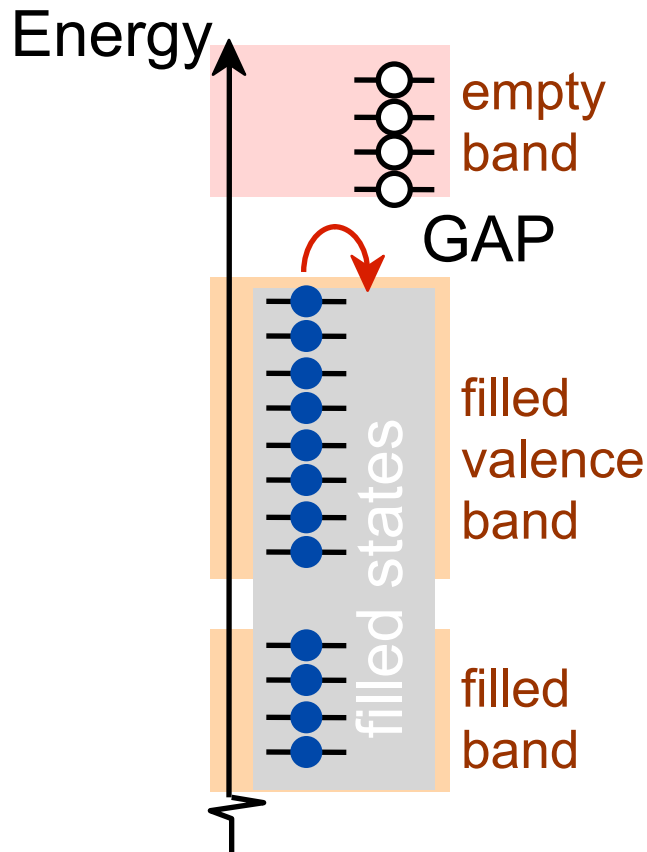


- Energy States:
- for metals nearby energy states are accessible by thermal fluctuations.



Energy States: Insulators & Semiconductors

- Insulators:
 - Higher energy states not accessible due to gap (> 2 eV).
- Semiconductors:
 - Higher energy states separated by smaller gap (< 2 eV).

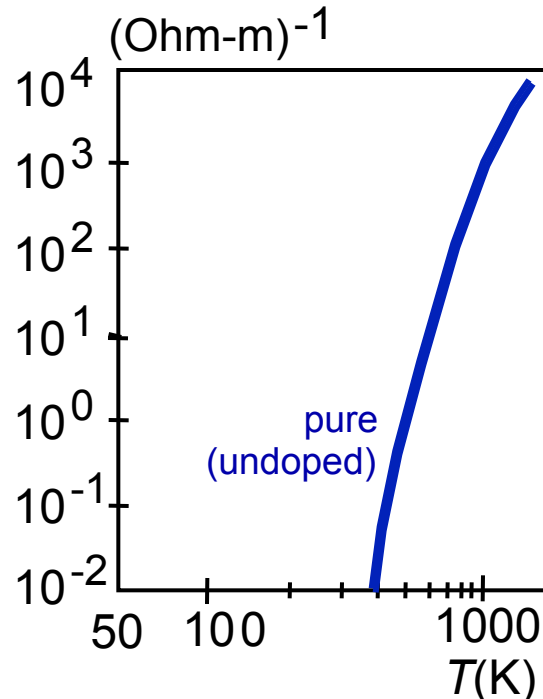


Pure Semiconductors: Conductivity vs T

- Data for **Pure Silicon**:

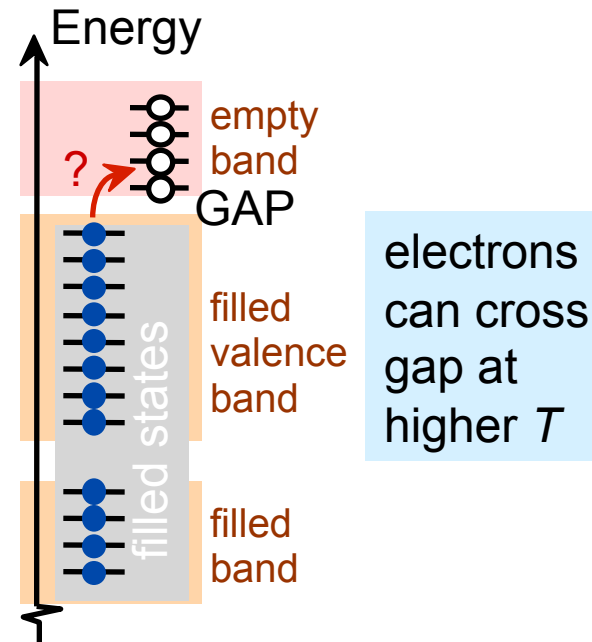
- σ increases with T
- opposite to metals

electrical conductivity, σ



Adapted from Fig. 19.15, *Callister 5e*. (Fig. 19.15 adapted from G.L. Pearson and J. Bardeen, *Phys. Rev.* **75**, p. 865, 1949.)

$$\sigma_{\text{undoped}} \propto e^{-E_{\text{gap}} / kT}$$



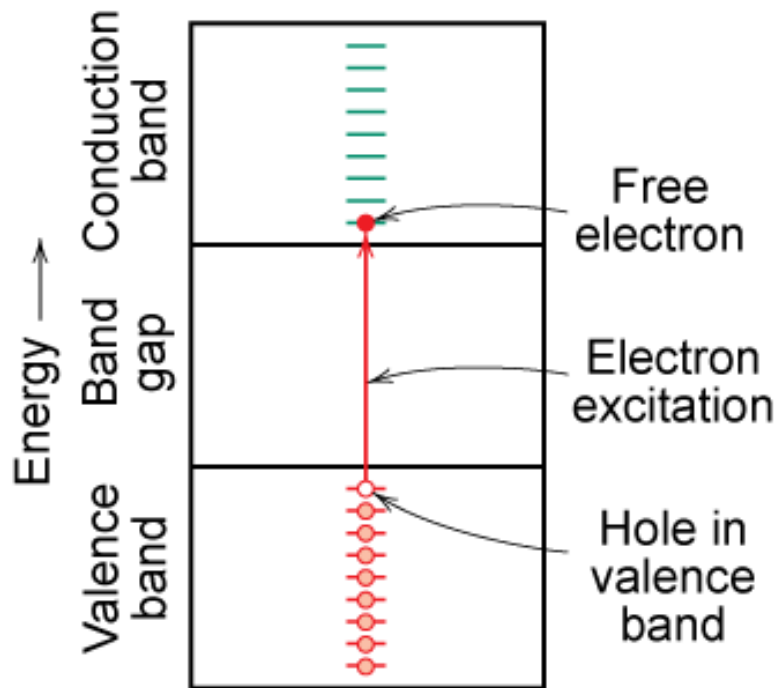
material	band gap (eV)
Si	1.11
Ge	0.67
GaP	2.25
CdS	2.40

Selected values from Table 18.3, *Callister 7e*.



Charge Carriers

Adapted from Fig. 18.6 (b), Callister 7e.



Two charge carrying mechanisms

Electron – negative charge

Hole – equal & opposite positive charge

Move at different speeds - **drift velocity**

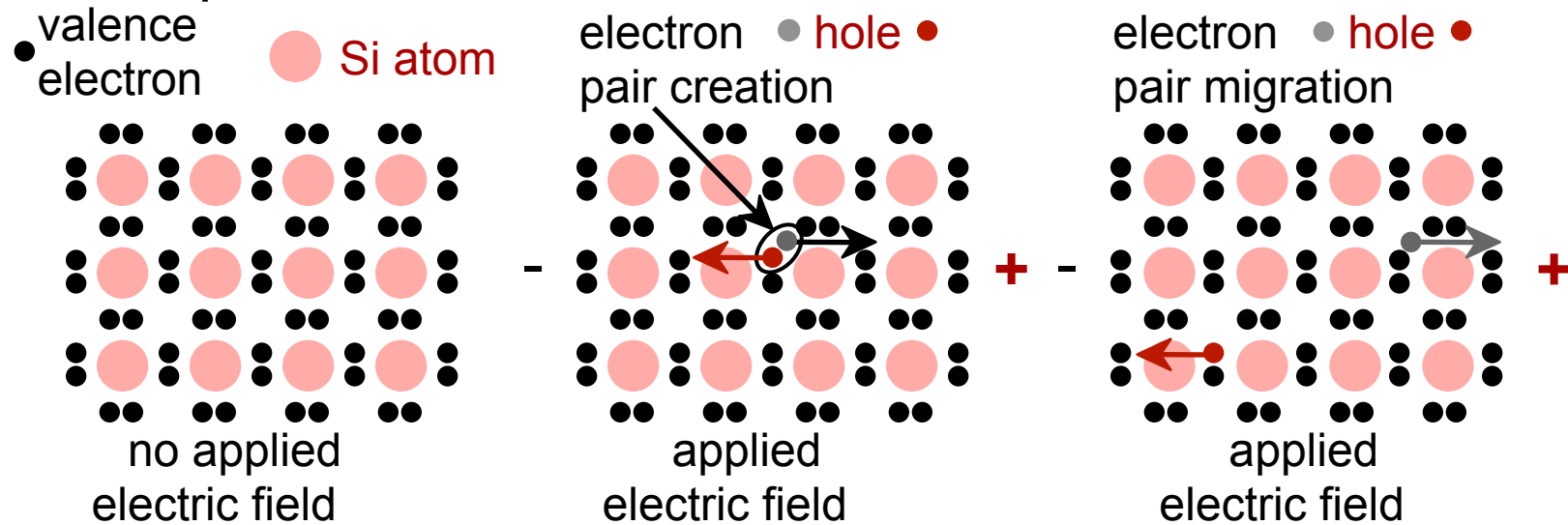
Higher temp. promotes more electrons into the conduction band

$\therefore \sigma \uparrow$ as $T \uparrow$

Electrons scattered by impurities, grain boundaries, etc.

Conduction in Terms of Electron and Hole Migration

- Concept of electrons and holes:



Adapted from Fig. 18.11, Callister 7e.

- Electrical Conductivity given by:

$$\sigma = n|e|\mu_e + p|e|\mu_h$$

electrons/m³ → n

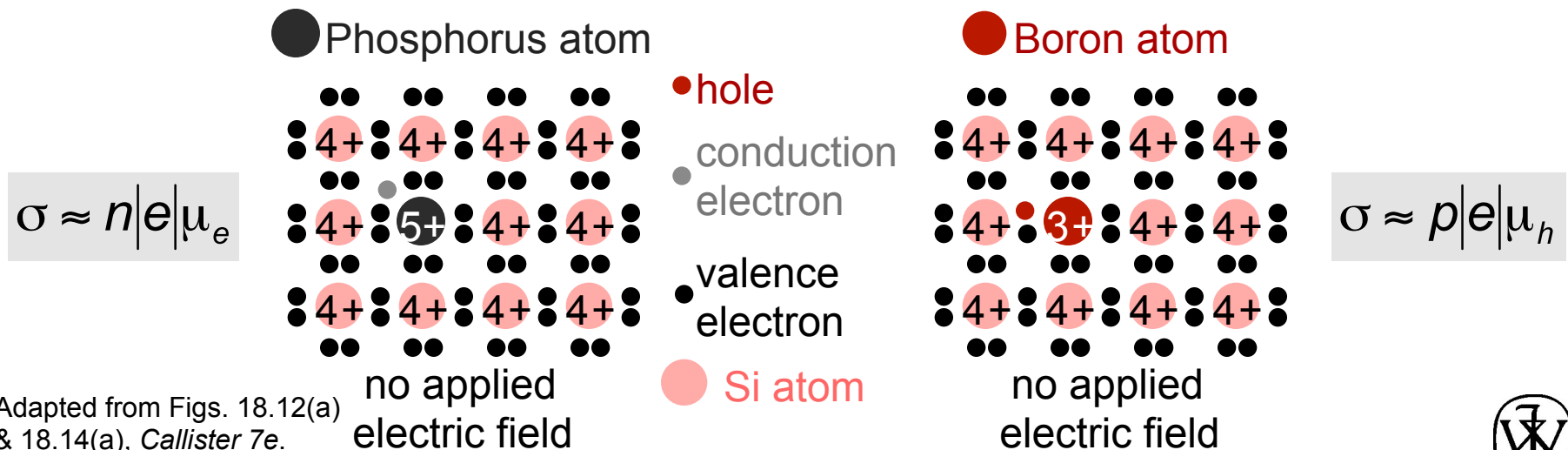
electron mobility → μ_e

holes/m³ → p

hole mobility → μ_h

Intrinsic vs Extrinsic Conduction

- **Intrinsic:**
electrons = # holes ($n = p$)
--case for pure Si
- **Extrinsic:**
-- $n \neq p$
--occurs when impurities are added with a different # valence electrons than the host (e.g., Si atoms)
- **n -type Extrinsic:** ($n \gg p$) • **p -type Extrinsic:** ($p \gg n$)



Adapted from Figs. 18.12(a)
& 18.14(a), Callister 7e.

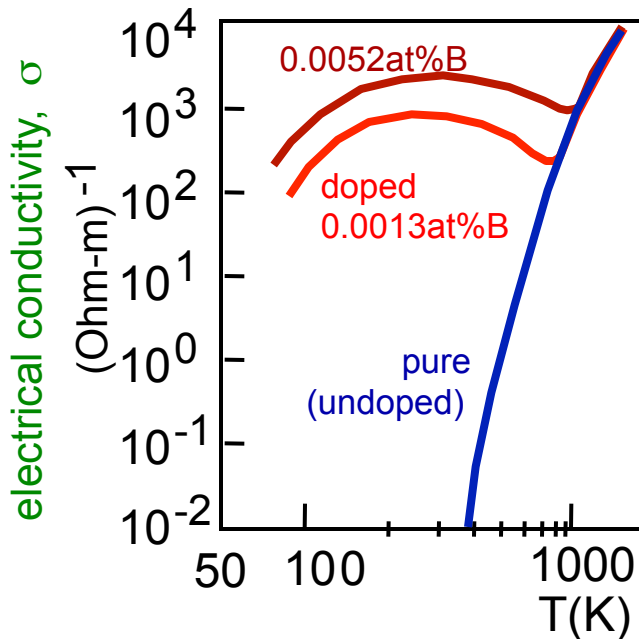


Intrinsic Semiconductors

- Pure material semiconductors: e.g., silicon & germanium
 - Group IVA materials
- Compound semiconductors
 - III-V compounds
 - Ex: GaAs & InSb
 - II-VI compounds
 - Ex: CdS & ZnTe
 - The wider the electronegativity difference between the elements the wider the energy gap.

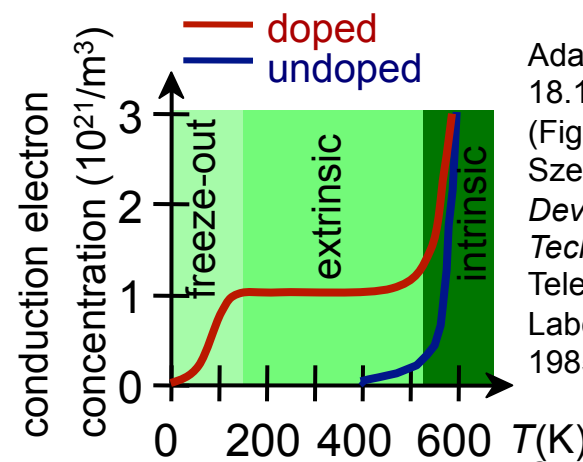
Doped Semiconductor: Conductivity vs. T

- Data for **Doped Silicon**:
 - σ increases doping
 - reason: imperfection sites lower the activation energy to produce mobile electrons.



Adapted from Fig. 19.15, *Callister 5e*. (Fig. 19.15 adapted from G.L. Pearson and J. Bardeen, *Phys. Rev.* **75**, p. 865, 1949.)

- Comparison: **intrinsic** vs **extrinsic** conduction...
 - extrinsic doping level: $10^{21}/\text{m}^3$ of a n -type donor impurity (such as P).
 - for $T < 100$ K: "freeze-out", thermal energy insufficient to excite electrons.
 - for $150 \text{ K} < T < 450 \text{ K}$: "extrinsic"
 - for $T \gg 450 \text{ K}$: "intrinsic"



Adapted from Fig. 18.17, *Callister 7e*. (Fig. 18.17 from S.M. Sze, *Semiconductor Devices, Physics, and Technology*, Bell Telephone Laboratories, Inc., 1985.)

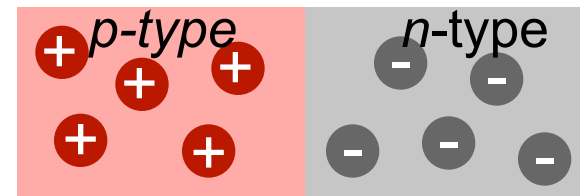


p-n Rectifying Junction

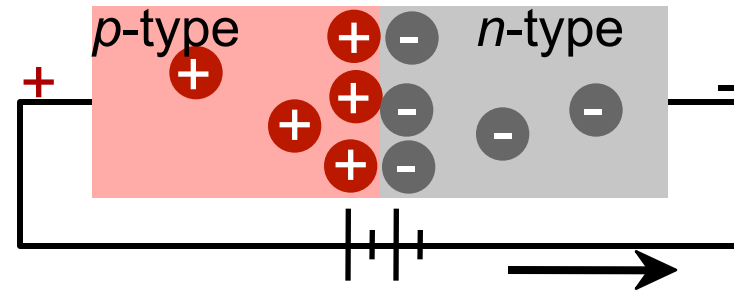
- Allows flow of electrons in one direction only (e.g., useful to convert alternating current to direct current).
- Processing: diffuse P into one side of a B-doped crystal.
- Results:

Adapted from Fig. 18.21,
Callister 7e.

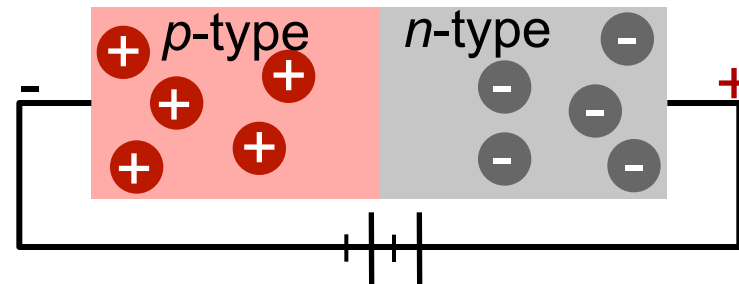
--No applied potential:
no net current flow.



--Forward bias: carrier
flow through *p*-type and
n-type regions; holes and
electrons recombine at
p-n junction; current flows.



--Reverse bias: carrier
flow away from *p-n* junction;
carrier conc. greatly reduced
at junction; little current flow.



Properties of Rectifying Junction

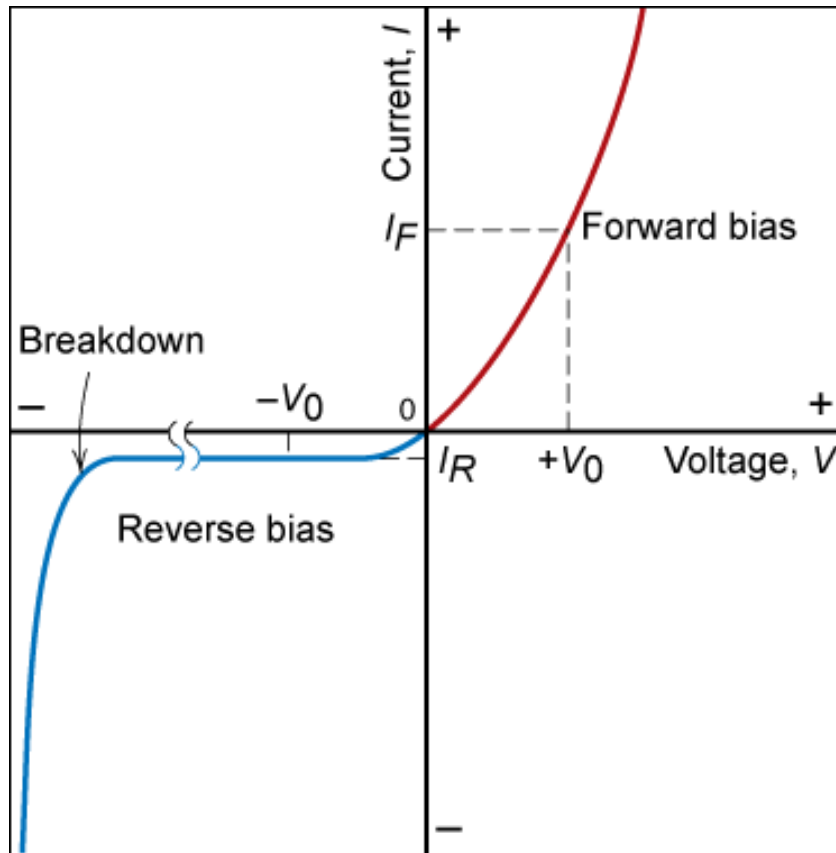


Fig. 18.22, Callister 7e.

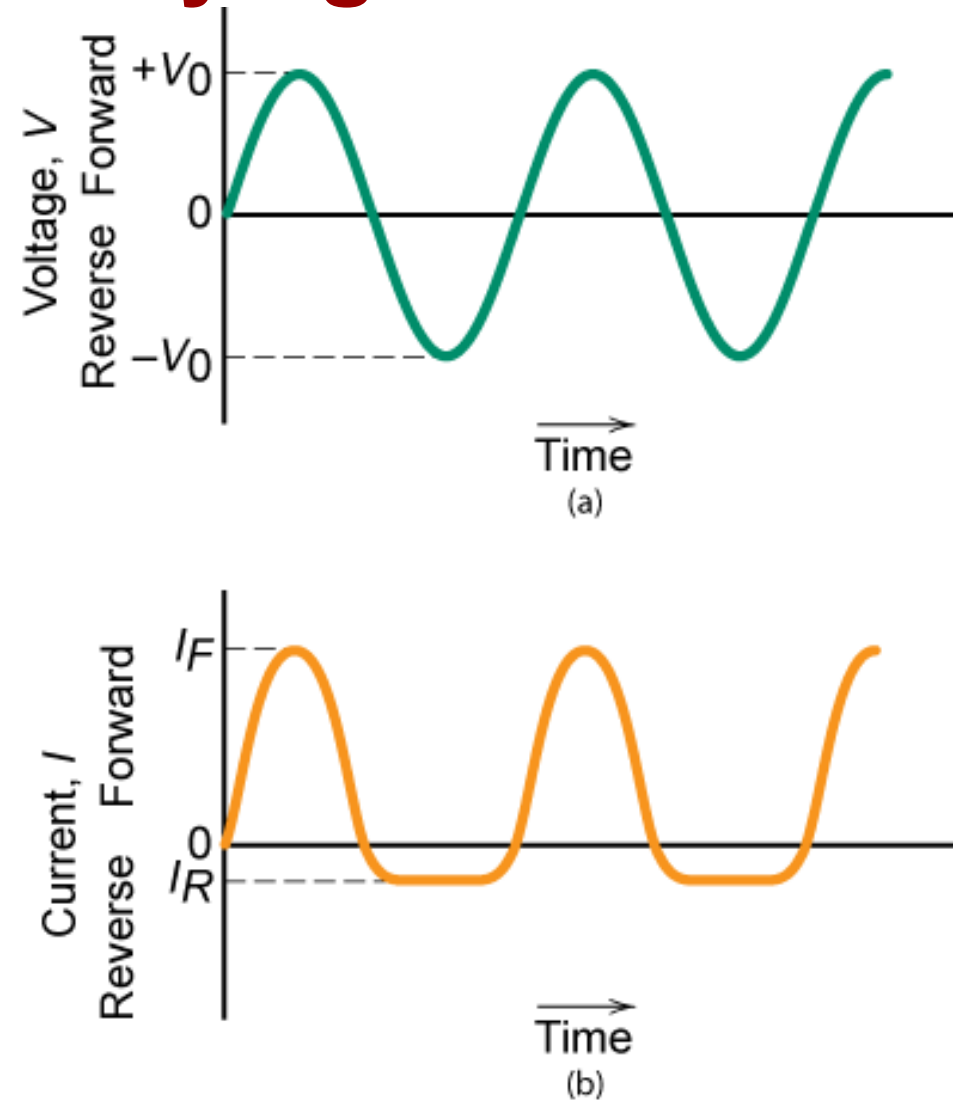


Fig. 18.23, Callister 7e.



Integrated Circuit Devices

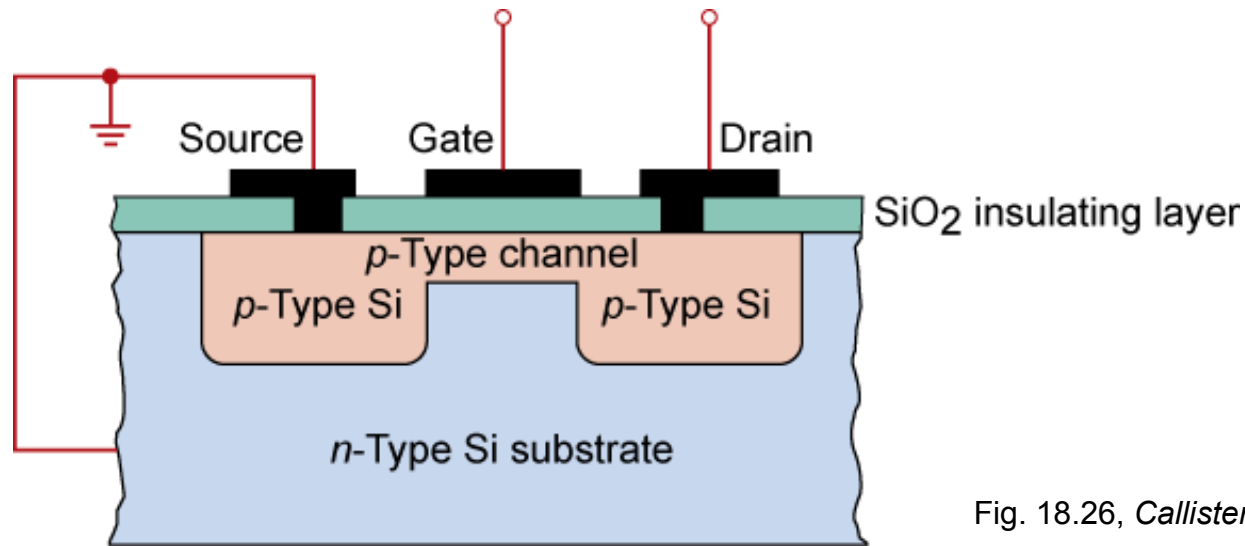
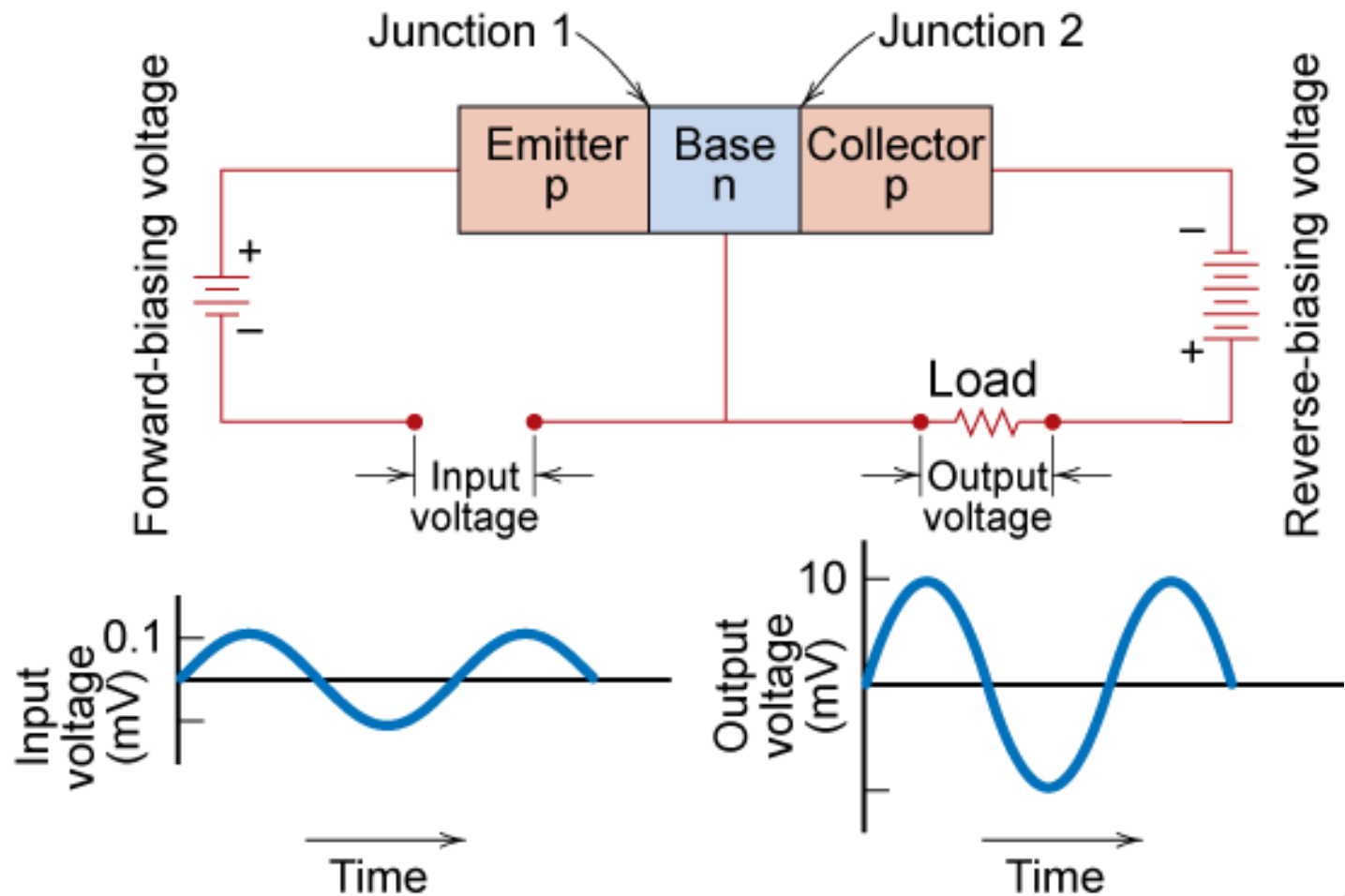


Fig. 18.26, Callister 6e.

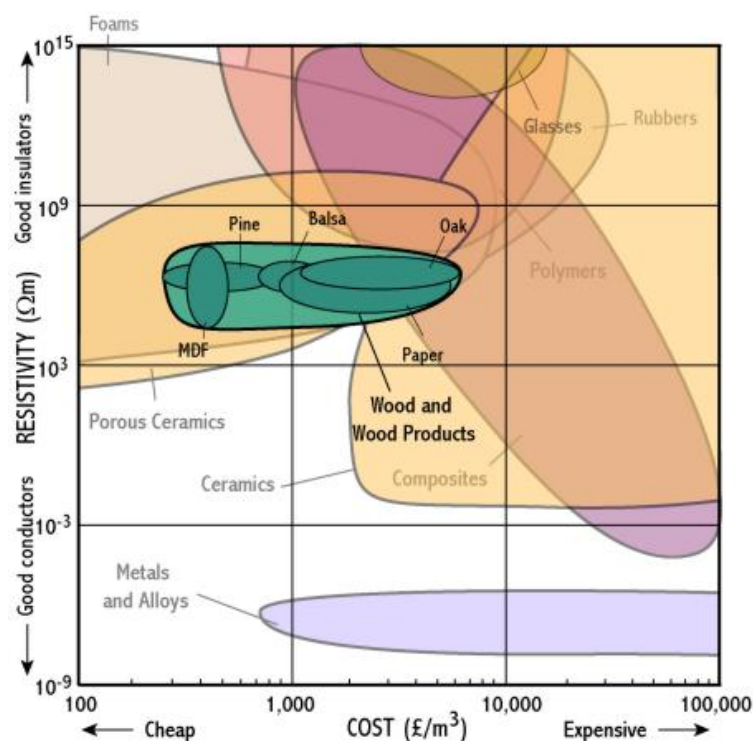
- Integrated circuits - state of the art ca. 50 nm line width
 - 1 Mbyte cache on board
 - $> 100,000,000$ components on chip
 - chip formed layer by layer
 - Al is the “wire”

Transistor MOSFET

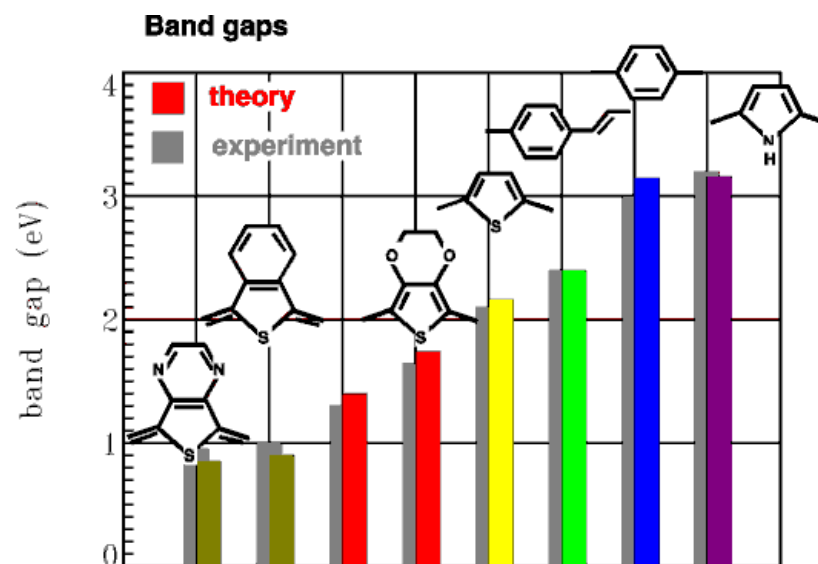
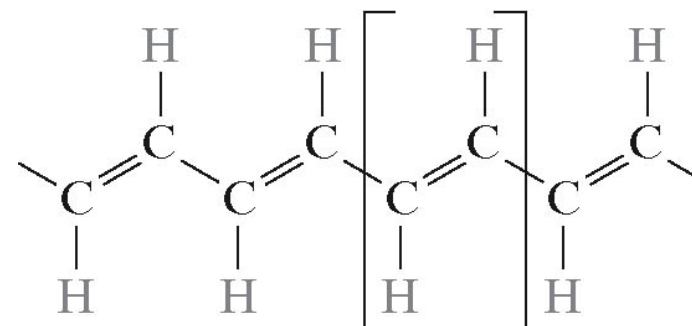
- MOSFET (metal oxide semiconductor field effect transistor)



Electrical Properties of Polymers



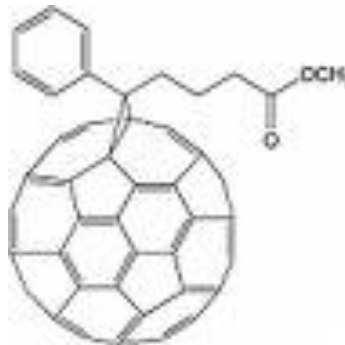
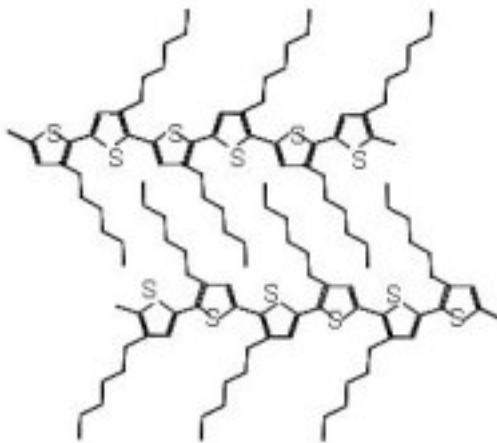
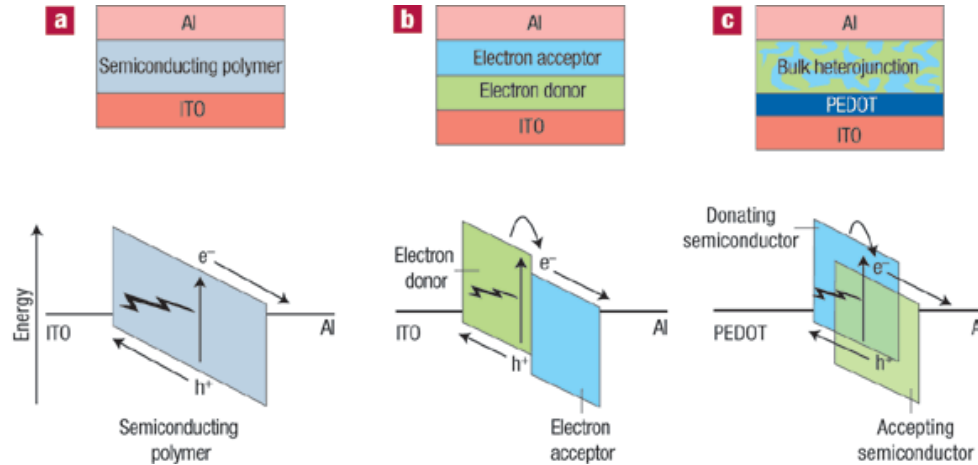
http://www-materials.eng.cam.ac.uk/mpsite/interactive_charts/resistivity-cost/NS6Chart.html



http://www.infochembio.ethz.ch/links/en/polymer_leitend.html



Polymer Solar Cells



ehf.uni-oldenburg.de

UNISOLAR® photovoltaic laminates

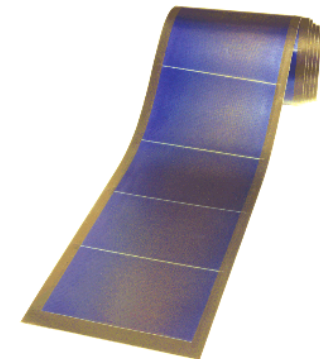


Photo courtesy of United Solar Ovonix, LLC

Nature Materials **5**, 675 - 676 (2006)



Summary

- Electrical **conductivity** and **resistivity** are:
 - material parameters.
 - geometry independent.
- Electrical **resistance** is:
 - a geometry and material dependent parameter.
- Conductors, semiconductors, and insulators...
 - differ in accessibility of energy states for conductance electrons.
- For metals, conductivity is increased by
 - reducing deformation
 - reducing imperfections
 - decreasing temperature.
- For pure semiconductors, conductivity is increased by
 - increasing temperature
 - doping (e.g., adding B to Si (*p*-type) or P to Si (*n*-type)).

